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Reg. No. :

$\textbf{Question Paper Code: X\,85838}$

M.E./M.Tech. DEGREE EXAMINATIONS, NOVEMBER/DECEMBER 2020 First Semester Manufacturing Engineering MF 5101 – ADVANCES IN MANUFACTURING TECHNOLOGY (Regulations 2017)

Time : Three Hours

Maximum : 100 Marks

Answer ALL questions

PART - A

(10×2=20 Marks)

- 1. Write short notes on isotropic machining.
- 2. Highlight the process capabilities of ultrasonic machining process.
- 3. What are the important process parameters in ELID process ?
- 4. List down the drawbacks of binderless wheels.
- 5. Highlight the scope of warm forging.
- 6. State the advantages of isostatic pressing.
- 7. Write short notes on size effect in micromachining.
- 8. Define epitaxy technique.
- 9. Define critical exposure in stereolithography.
- 10. Compare surface modification and surface coating processes.

PART – B (5×13=65 Marks)

11. a) Explain the process of electric discharge machining. Highlight its process capabilities.

(OR)

b) Explain the process of electro chemical machining. Derive a relation for the material removal rate in electro chemical machining.

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12. a) Explain in detail about a spherical surface and define the various surface parameters.

(OR)

| b) With neat sketch, explain the process of chemical mechanical p | polishing. |
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| 13. a) i) Compare hot and cold isostatic pressing. | (3) |
| ii) Explain the process of hydroforming and mention its limitat | tions. (10) |
| (OR) | |
| b) Write short notes on the following : | |
| i) Orbital forging. | (4) |
| ii) Isothermal forging. | (4) |
| iii) High speed extrusion. | (5) |
| 14. a) Explain the process of ion beam etching with neat diagram. | |
| (OR) | |
| b) i) Write short notes on chip formation in micromachining. | (5) |
| ii) Explain in detail about sub micron lithographic technique. | (8) |
| 15. a) i) Explain the generic process of rapid prototyping process. | (7) |
| ii) Classify the different surface modification processes. | (6) |
| (OR) | |
| b) Explain the process of selective laser sintering and explain the m recycling process. | ethod of powder |
| PART - C | (1×15=15 Marks) |
| 16. a) Write short notes on the following : | |
| i) Photopolymerization. | (5) |
| ii) Sintering mechanism in selective laser sintering. | (10) |
| (OR) | |
| b) Write short notes on the following : | |
| i) Process parameters of powder rolling process. | (7) |
| ii) Stresses in high speed grinding wheels. | (8) |
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